

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

HIROHAMA et al

Atty. Ref.: 900-408

Serial No. **Unknown**

Group:

Filed: **November 19, 2001**

Examiner:

For: **METHOD OF MANUFACTURING SEMICONDUCTOR
DEVICE**

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November 19, 2001

Assistant Commissioner for Patents
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

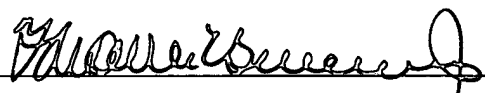
Sir:

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the reference listed on the attached form PTO-1449, a copy of which is enclosed. This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited. The reference is referred to at page 5, lines 14-15 of the instant application specification.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached reference has been considered and made of record.

Respectfully submitted,

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